Ergo: Repeatable Results in Minutes

Ergo is the all-new software interface for Asylum Research Cypher and Jupiter atomic force microscopes. Based on the powerful Oxford Instruments AZtec® software platform, it improves productivity for both infrequent users and experts. With a streamlined workflow for quick AFM setup and simplified acquisition of high-quality images, Ergo users will more quickly be able to complete their measurements and confidently draw meaningful conclusions.

Auto AFM Calibration in Seconds

Ergo’s workflow makes setting up the AFM quick and simple for anyone. Go from loading a new probe to aligning the laser with only a few clicks. In the background, Asylum’s proprietary GetReal™ technology automatically calibrates the cantilever each time to help ensure the most consistent results from day-to-day. This makes it easy to quickly image multiple samples.

Rapid Generation of High-Quality Images

Ergo has embedded Asylum’s proprietary AutoPilot™ algorithm, which automatically calculates the optimal imaging settings. AutoPilot™ works with all modes in Ergo and starts producing high-quality data from the first scan line.

Minimal Training Required

Ergo shares a common core and workflow concept with the Oxford Instruments AZtec software for SEM and TEM analyzers. This tried and tested platform allows users to focus on results and not on the equipment.

SEBS triblock copolymer
Tapping mode phase image of a triblock copolymer (SEBS) spuncoat onto a silicon wafer, 1 µm scan. The cover image shows the same sample but a 7 µm scan.
The Future of AFM Control

Ergo user interface is simple and uncluttered
A clear workflow guides users through setup and allows them to start imaging quickly. Only a few key parameters are shown by default.

Watch a video introduction at: AFM.oxinst.com/Ergo
Automated Image Optimization Works on a Wide Variety of Sample Types

Asylum's AUTOPILOT algorithm has been developed to work on all sample types commonly found in academic and industrial research, even very challenging samples like those that are very rough or exhibit high tip-sample adhesion. Here are just a few examples:

**Silicon wafer**
Substrate roughness is one of the most common AFM measurements. Ergo makes it simple and repeatable.

**PMR disk drive media**
Roughness and defects are key quality control metrics on disk drive media that affect data storage density.

**Polymer blend**
AFM is a powerful tool for visualizing the microstructure of polymers, here a polystyrene-polycaprolactone blend.

**PTFE membrane**
Ergo easily achieves high resolution using AUTOPILOT, here resolving the individual PTFE molecule chains.

**Silicon wafer**
Substrate roughness is one of the most common AFM measurements. Ergo makes it simple and repeatable.

Advanced Mode Operation

Ergo works in concert with Asylum's IGOR Pro-based software that is supplied with every system. Expert users have the ability to operate “advanced modes” and exercise the full customization capabilities of the AFM. The combination of the two provides users an unmatched flexibility.

“Ergo has made the high performance of our Cypher AFM accessible to more users at our facility, including those who are newer and less experienced with AFM.”

Justin Jureller, PhD, MRSEC MPML Manager, University of Chicago
Easily Analyze and Present AFM Images

AFM images can be analyzed directly in Ergo without the need for other software. A workflow guides the user to sort, process, and analyze AFM data. Results are stored directly with the images so they cannot be lost, and the raw data is never altered.

Measuring the height differences between two regions on a polymer sample.

Measuring the height of a feature on a line section.
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Learn more about Ergo: https://AFM.oxinst.com/Ergo

Measuring roughness parameters on several material types.

<table>
<thead>
<tr>
<th>Image</th>
<th>Average Deviation</th>
<th>Standard Deviation</th>
<th>Height Range</th>
<th>Skew</th>
<th>Kurtosis</th>
</tr>
</thead>
<tbody>
<tr>
<td>GlossyPaper.h5</td>
<td>22.1 nm</td>
<td>21.6 nm</td>
<td>31.2 nm</td>
<td>-1.4709</td>
<td>6.2097</td>
</tr>
<tr>
<td>GorillaGlass.h3</td>
<td>1.69 nm</td>
<td>1.32 nm</td>
<td>12.8 nm</td>
<td>0.3950</td>
<td>2.7381</td>
</tr>
<tr>
<td>HardDiskDrive.h3</td>
<td>484 pm</td>
<td>613 pm</td>
<td>5.7 nm</td>
<td>0.2625</td>
<td>3.1589</td>
</tr>
<tr>
<td>SiliconWafer.h5</td>
<td>164 pm</td>
<td>266 pm</td>
<td>1.82 nm</td>
<td>0.6184</td>
<td>3.2576</td>
</tr>
</tbody>
</table>

Polished silicon wafer

Glass disk drive media substrate

Chemically strengthened display glass

Coated photo paper